

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

TI-36795

Richard B. Irwin, et al.

Examiner: Thomas L. Dickey

Serial No: 10/814,673

Art Unit: 2826

Filed: 03/30/04

For: Dual Metal Schottky Diode

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Karen Vertz
Karen Vertz

8-11-05
Date

Dear Sir:

In the matter of the above-identified application, Applicants are submitting herewith copies of documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

In accordance with 37 CFR 1.97 (c), this Information Disclosure statement is being submitted before the mailing date of a Notice of Allowance.

Furthermore, in accordance with 37 CFR 1.97(e)(1), I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Pursuant to 37 CFR 1.97(d), Applicants respectfully petition that this Information Disclosure Statement be considered by the Examiner.

Please charge any fees due in connection with the filing of this paper to the Deposit Account No. 20-0668 of Texas Instruments Incorporated, and please credit any excess fees to such Deposit Account. **This form is submitted in triplicate.**

Respectfully submitted,



Rose Alyssa Keagy

Attorney for Applicants

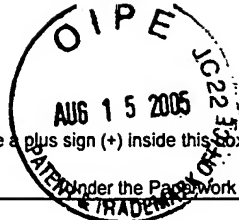
Reg. No. 35,095

Texas Instruments Incorporated

P.O. Box 655474, MS 3999

Dallas, TX 75265

(972) 917-4167



Please type a plus sign (+) inside this box →



PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for Form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete If Known	
				Application Number	10/814,673
				Filing Date	03/30/04
				First Named Inventor	Richard B. Irwin, et al.
				Group Art Unit	2826
				Examiner Name	Thomas L. Dickey
Sheet	1	of	1	Attorney Docket No.	TI-36795

U.S. PATENT DOCUMENTS						
Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	AA	4,491,860		Lim	1/1/85	
	AB	2003/0087482		Hwang et al.	5/8/03	
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

FOREIGN PATENT DOCUMENTS								
Exam. Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ² (if known)				
	BA	UK	2 112 566 A		Bartur et al.	7/20/83		
	BB							
	BC							
	BD							
	BE							
	BF							
	BG							

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	TAKANO HISANAGA, ET AL. "Semiconductor Element and Method for Manufacturing the Same" Patent Abstracts of Japan, Publication No. 2003-197924, 7/11/03	
	CB		
	CC		
	CD		
	CE		
	CF		
	CG		

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

US and Foreign Patent Documents: ¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

Other Prior Art/Non-Patent Literature Documents: ¹Unique citation designation number. ²Applicant is to place a check mark here if English Translation is attached.